

EddyCus® map 2530RMT – Resistivity Imaging Device

P 2530RMT 21



Highlights

- ► Contact-free imaging
- ► High speed (10,000 points in 5 min)
- ► Repeatable and accurate
- ► High resolution (9 to 90,000 points)
- ► Mapping of encapsulated layers
- ▶ Homogeneity and defect imaging

Processes

- ► Classification and sorting
- ▶ Ingot casting and drawing (FZ, CZ)
- ▶ Implantation and doping
- ► Annealing and tempering
- ▶ Composition & structure assessment
- ▶ Melting, sintering, heat treatment
- EDM processability

Materials

► Wafer resistivity imaging

Applications

- ▶ Ingot and boule resistivity imaging
- ► Sputter target composition imaging
- ► Purity assessment
- ► Electrical discharge machining
- ▶ Material sorting (map: homogeneity assessment)
- ► Melting, casting, sintering
- ► Defect imaging and integrity assessment

- Semiconductors
 - ► Si (mono, poly)
 - ► SiC, SiSiC
 - ► GaAs
- ► GaN
- Alloys
- ▶ Metals
- ► Graphite ► Graphene
- ▶ Compounds
- ▶ Composites

SURAGUS GmbH Maria-Reiche-Strasse 1 01109 Dresden Germany

For further questions: +49 351 32 111 520

Visit us at:

www.suragus.com

www.suragus.com/calculator

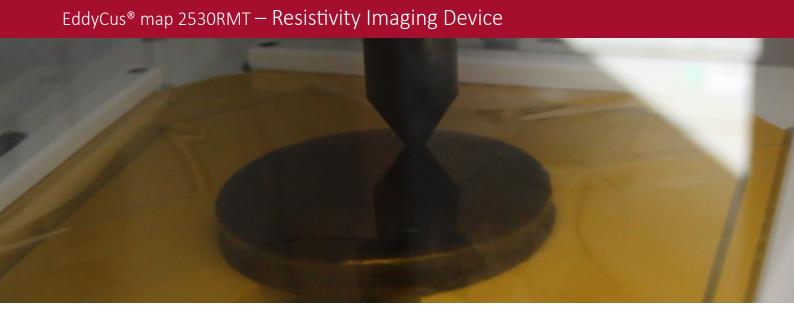
www.suragus.com/EddyCusMap2530

Engineered and Made in Germany







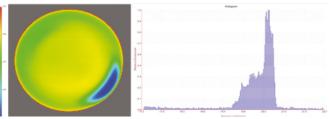


Measurement technology	High frequency eddy current sensor
Substrates	Boules, pucks, wafers
Max. scanning area	8 inch / 205 mm x 205 mm x 100 mm
Edge effect correction / exclusion	2 – 10 mm (depending on size, range, setup and requirements)
Max. sample thickness / sensor gap	100 mm
Resistivity range	0.1 – 100 mOhm·cm (lower and higher on request)
Conductivity range	0.01 – 65 MS/m
Pitch	0.1 – 10 mm
Spot size (coil size)	1 – 9 mm (depending on coil size)
Penetration depth (frequency)	$1-10 \ \text{mm}$ (depending on frequency)
Speed	150 mm per second (time 1 to 30 minutes)
Device dimensions (w/h/d) / weight	31.5" x 19.1" x 33.5" / 785 mm x 486 mm x 850 mm / 90 kg
Further available features	Sheet resistance imaging, metal layer thickness imaging, advanced impedance spectroscopy using EddyEVA

Device Control and Software

- Pre-defined measurement and product recipes (sizes, pitches, thresholds)
- ▶ Line scan, histogram and area analysis
- ▶ Black and colored image coding
- ► Csv & pdf export
- ▶ SPC summary and export
- ▶ 3 user levels
- ▶ Material database for parameter conversion
- ▶ Edge effect compensation
- ► Storage and import of data
- ► Export of data sets (e.g. to EddyEva, MS Excel, Origin)

Boule Resistivity Imaging – Histogram View



Advanced Impedance Spectroscopy by EddyEVA Software

